

Electronic Patent Application Fee Transmittal				
Application Number:	10552984			
Filing Date:	25-Sep-2006			
Title of Invention:	Test structure for electrically verifying the depths of trench-etching in an soi wafer, and associated working methods			
First Named Inventor/Applicant Name:	Ralf Lerner			
Filer:	James L. Rowland/Christopher Rosenthal			
Attorney Docket Number:	P28504			
Filed as Large Entity				
U.S. National Stage under 35 USC 371 Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Claims in excess of 20	1615	7	52	364
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension - 3 months with \$0 paid	1253	1	1110	1110
Miscellaneous:				
Total in USD (\$)				1474